



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

the application of

Satoshi HASHIMOTO et al.

: Confirmation No. 4782

Serial No. 10/573,567

: Attorney Docket No. 2006_0370A

Filed March 27, 2006

: Group Art Unit 1794

: Examiner Jennifer A. Chriss

VINYLDENE FLUORIDE RESIN
MONOFILAMENT AND PROCESS FOR
PRODUCING THE SAME

Mail Stop: AMENDMENT

PETITION FOR EXTENSION OF TIME

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEE FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975.

Sir:

Petition hereby is made for a one month extension of time to respond to the communication of March 17, 2008.

The fee of \$120.00 is

submitted herewith.
 to be charged to Deposit Account No. 23-0975. A duplicate copy of this Petition is enclosed.

 Small entity status of this application is established by a Small Entity Status Assertion which
 is enclosed.
 has been previously submitted.
 has been previously asserted.

The Commissioner is authorized to charge any deficiency or to credit any overpayment associated with this communication to Deposit Account No. 23-0975, with the EXCEPTION of deficiencies in fees for multiple dependent claims in new applications.

Respectfully submitted,

Satoshi HASHIMOTO, et al. 120.00 OP 00000052 10573567

By


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120.00 OP

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